

# AMAT P5000 (vintage : 1993)

## I . AMAT P5000 Configuration

Equipment Type	: P5000
Equipment S/N	:
Equipment production time	: 06-05-1993
Wafer size	: 6inch
Wafer Type	:
Heater Type	: Susceptor
Chamber Type	: DLH
Process Type	: TEOS

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## III. Missing Part List

<u>controller</u> <u>box#1</u>	<u>SBC</u>
<u>controller</u> <u>box#2</u>	<u>+15V PS</u> <u>OPTO#2</u>
<u>Chamber B</u>	<u>C. M gauge</u>
<u>AC BOX</u>	<u>CB4 LAMP/MAG A</u>